## Advanced threshold voltage extraction methodologies for GaN High Electron Mobility Transistors

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As GaN High Electron Mobility Transistors (HEMTs) find more applications in RF and analog IC design, methods for their characterization need to be either invented or adapted from previously gathered expertise. In this work a methodology for the extraction of the Threshold Voltage parameter, initially developed for MOSFET devices is shown to be applicable to HEMTs as well. The device used for this end is a wide-long (W=250um, L=3um) AlGaN/GaN HEMT fabricated by IESL-FORTH, measured at temperatures ranging from -30°C, up to 110°C at the Electronics Laboratory at TUC using an HP 4142B Modular DC SMU and a probe station with a Temptronic TPO3000 temperature-controlled chuck.

The V<sub>TH</sub> extraction methodology used in this work is continuously applicable to the whole spectrum of Drain biases and can be summarized as follows. The transconductance to current ratio for all regions of operation is given by:  $\frac{G_m \cdot U_T}{I_D} = \frac{1}{n \cdot (1+q_s+q_d)}$ , n being the subthreshold slope factor and U<sub>T</sub> the thermal voltage. Using the charge-voltage relationship<sup>[2]</sup>,

 $V_P-V_X=U_T[2q_x+ln(q_x)]$ , the pinch-off voltage  $V_p=(V_G-V_{TH})/n$  can be calculated for an arbitrary point x along the channel as a function of the mobile charge density at x,  $q_x$ . Rearranging and solving for  $q_x$ ,  $q_x=0.5W_0[2e^{(V_P-V_X)/U_T}]$ ,  $W_0$  being the Lambert-W function, and returning to the  $G_m/I_D$  formula, under the threshold condition  $V_P=V_S$ , a singular point on the  $G_m/I_D$  curve can be calculated <sup>[3]</sup>, which corresponds to the threshold voltage,  $V_{TH}$ .

$$Z \stackrel{\text{def}}{=} \frac{G_m \cdot U_T}{I_D} \cdot n = \frac{1}{1.4263 + 0.5W_0(2e^{-V_{DS}/U_T})}$$

Fig.1b demonstrates the ease of application of the methodology to experimental  $G_m U_T/I_D$  vs.  $V_{GS}$  data, produced for all temperatures from the measured transfer characteristics  $I_D$  vs.  $V_{GS}$  such as those shown in Fig.1a (T=30°C).

In order to verify the applicability of this methodology to HEMT devices, the extraction was carried out as described and compared to an industry standard, the charge-based Adjusted Constant Current  $(ACC)^{[4]}$  technique. The resulting plots of  $V_{TH}$  versus temperature (Fig.2a) and versus  $V_{DS}$  (Fig.2b) show a maximum deviation of 30mV between the two methods, over the whole temperature and  $V_{DS}$  bias range, with the  $G_m/I_D$  method producing both qualitative and quantitative results similar to the ACC method.





Fig. 1. (a) Family of DC transfer curves measured at T=30°C for Drain bias levels [10mV, 4V]. (b) Resulting transconductance efficiency curves for four Drain bias levels (10mV, 500mV, 1V and 4V) at 30°C, depicting V<sub>TH</sub> extraction methodology described in <sup>[3]</sup> as applied in this work.



**Fig. 2.** Scaling of threshold voltage  $V_{TH}$  versus Temperature for the various Drain biases (a) and versus Drain bias for the whole temperature range measured (b). Dashed lines and open markers correspond to the Adjusted Constant Current method <sup>[4]</sup>, solid lines with filled markers to the Transconductance to Current Ratio method <sup>[3]</sup>.



methods coming to an almost complete agreement. In summary, the present  $G_m/I_D$  method is observed to yield remarkably consistent results with the proven Adjusted Constant Current method, and they can thus be used interchangeably depending on available data and application scope.

The similarity of the two methods can also be

 $(n_{\text{DIBL}} = \Delta V_{\text{TH}} / \Delta V_{\text{DS}})$  shown in Fig.3, with both

observed from the DIBL factor calculation

Fig. 3 DIBL factor as produced by the ACC method  $^{[4]}$  versus the  $G_m/I_D$  method  $^{[3]}$ .

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